

Inventor: Young Hun Seo
For: Method of Fabricating Silicon on Insulator Substrates for Use in Semiconductor
Devices
Attorney Docket No. 20059/PIA31199
Sheet 1 of 5

FIG. 1A
(PRIOR ART)

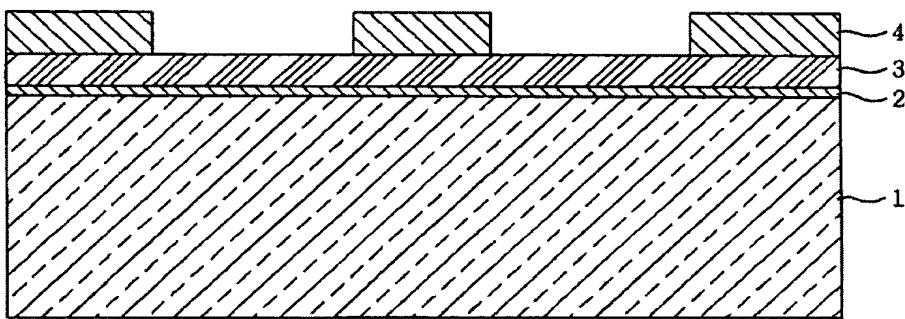


FIG. 1B
(PRIOR ART)

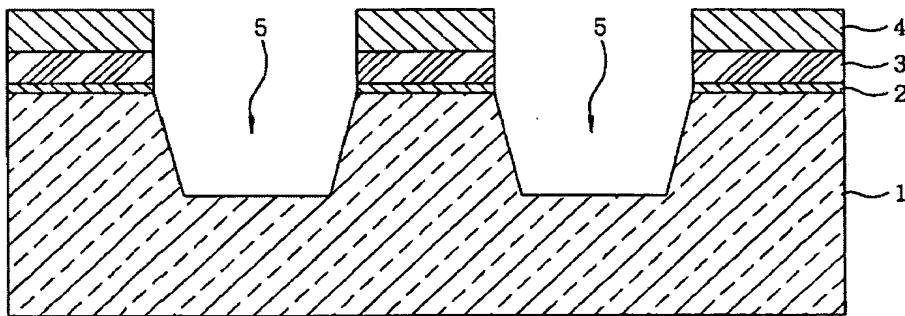


FIG. 1C
(PRIOR ART)

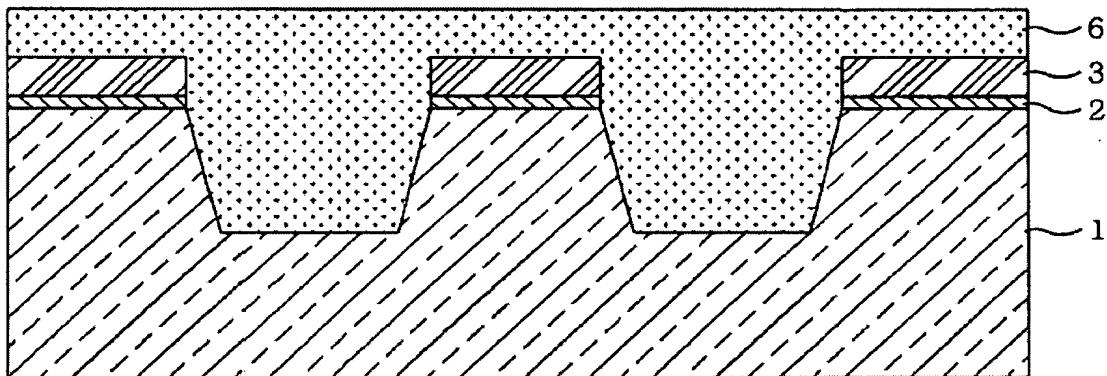


FIG. 1D
(PRIOR ART)

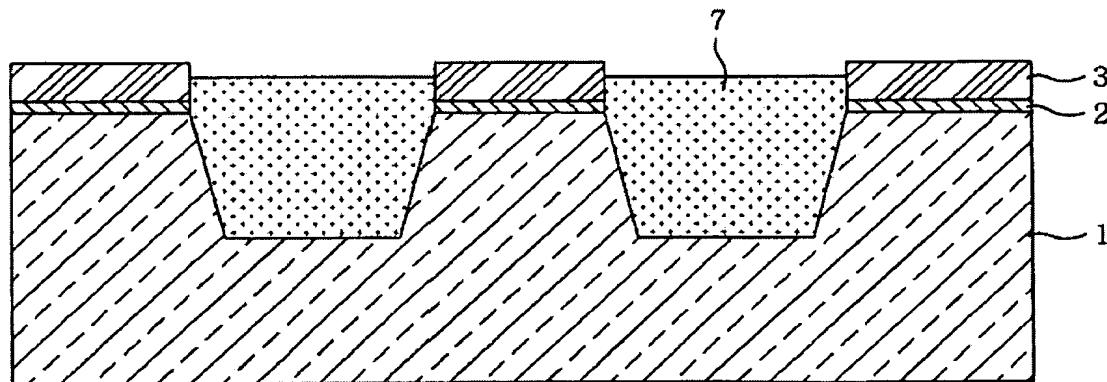


FIG. 2A

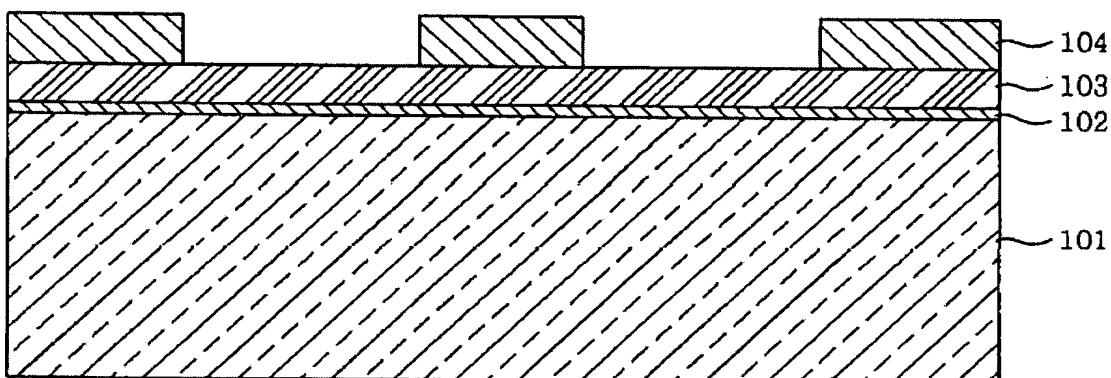


FIG. 2B

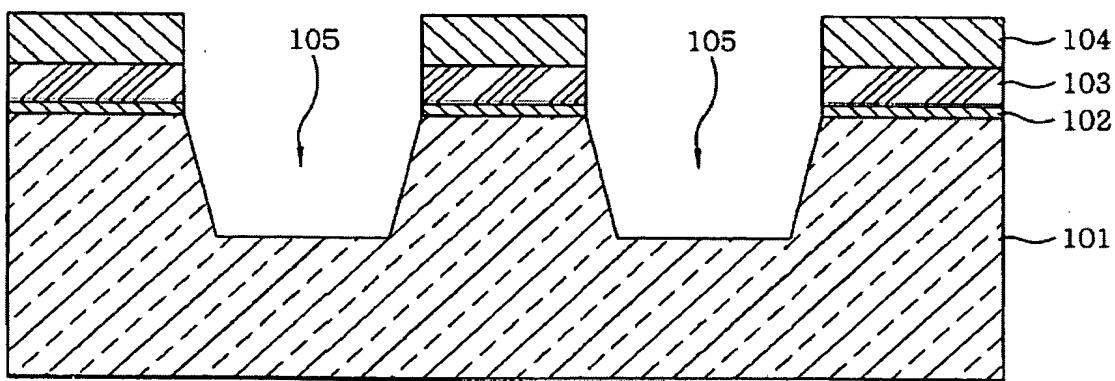


FIG. 2C

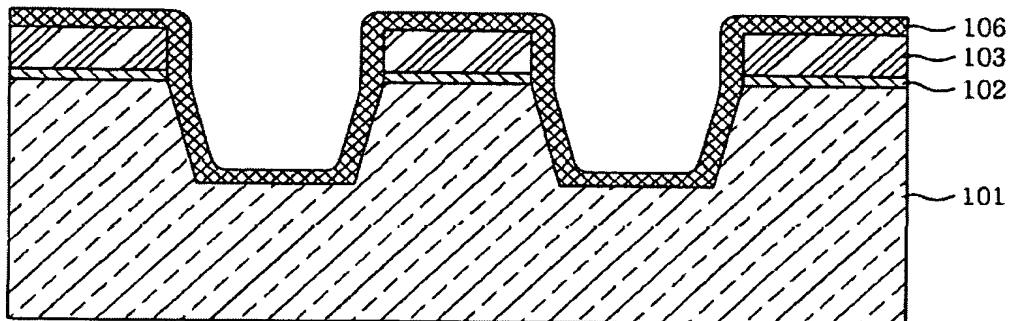


FIG. 2D

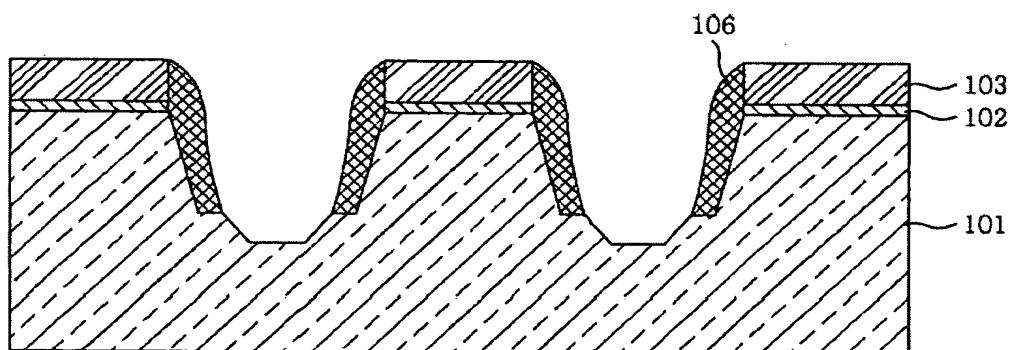


FIG.2E

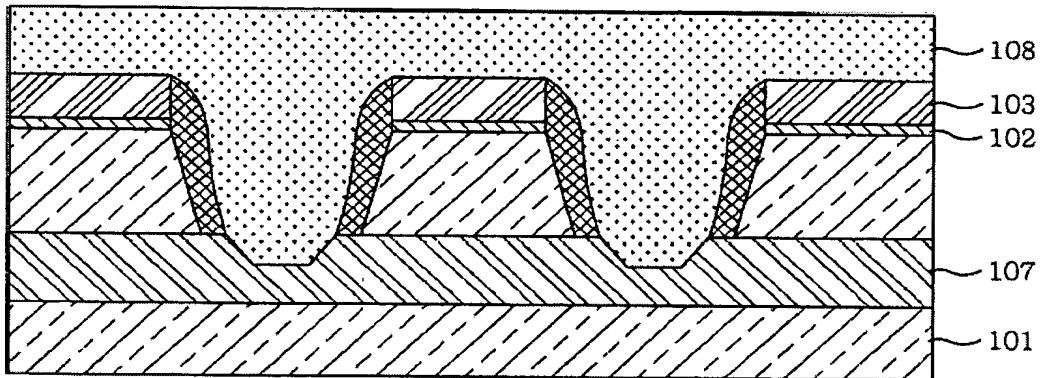


FIG.2F

